


<b>Search Notes</b> 	<b>Application/Control No.</b> 10762649	<b>Applicant(s)/Patent Under Reexamination</b> PARK, JOON
	<b>Examiner</b> DeMille, Danton	<b>Art Unit</b> 3771

SEARCHED			
Class	Subclass	Date	Examiner
601	15,16,18,19,24,26,94, 98-103, 115, 116	4/2/7	DDD

SEARCH NOTES		
Search Notes	Date	Examiner
EAST text search, see printout	4/2/7	DDD

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner